PATENT COOPERATION TREATY

PCT

INTERNATIONAL SEARCH REPORT

(PCT Article 18 and Rules 43 and 44)

Ī	Applicant's or agent's file reference	FOR FURTHER		see Form PCT/ISA/220					
	MI22-2663	ACTION	as well	as, where applicable, item 5 below.					
Ī	International application No.	International filing date (day/month/y	ear)	(Earliest) Priority Date (day/month/year)					
	PCT/US2004/027898	26/08/2004		04/09/2003					
ſ	Applicant								
	MICRON TECHNOLOGY, INC.								
	This International Search Report has been according to Article 18. A copy is being tra		ing Aut	nority and is transmitted to the applicant					
ļ	This International Search Report consists of a total of sheets.								
		a copy of each prior art document cite		report.					
	Basis of the report With record to the language, the	international search was carried out or	the has	sis of the international application in the					
		ess otherwise Indicated under this Item		or are manner appropriate in the					
	The International this Authority (Au		a transi	ation of the international application furnished to					
j			sclosed	in the international application, see 8ox No. I.					
	2. Certain claims were fou	nd unsearchable (See Box II).							
	3. Unity of invention is tacking (see Box III).								
	4. With regard to the title,								
		ibmitted by the applicant.							
ļ][shed by this Authority to read as follows	s:						
		•							
	5. With regard to the abstract,			•					
	the text is approved as su	bmitted by the applicant.							
	the text has been established, according to Rule 38.2(b), by this Authority as it appears in Box No. IV. The applicant may, within one month from the date of mailing of this international search report, submit comments to this Authority.								
	6. With regard to the drawings,								
		published with the abstract is Figure No	o. <u>19</u>						
	as suggested by	the applicant.							
	as selected by the	is Authority, because the applicant faile	ed to sug	ggest a figure.					
Ì	as selected by the	is Authority, because this figure better	characte	erizes the invention.					
	b. none of the figures is to b	e published with the abstract.							

Form PCT/ISA/210 /first sheet) (January 2004)

INTERNATIONAL SEARCH REPORT

ernational application No.

PCT/US2004/027898

Box No. IV Text of the abstract (Continuation of item 5 of the first sheet)

A method for forming double-sided capacitors for a semiconductor device includes forming a dielectric structure (86) which supports capacitor bottom plates (110) during wafer processing. The structure is particularly useful for supporting the bottom plates during removal of a base dielectric layer (84) to expose the outside of the bottom plates to form a double-sided capacitor. The support structure further supports the bottom plates during formation of a cell dielectric layer (200), a capacitor top plate (202), and final supporting dielectric (204). An inventive structure is also described.

Form PCT/ISA/210 (continuation of first sneet (3)) (January 2004-

INTERN TIONAL SEARCH REPORT

onal Application No PCT/US2004/027898

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 H01L21/8242 H01L27/108 H01L21/02

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols) IPC $\frac{7}{100}$ H01L

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical search terms used)

EPO-Internal

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Х	US 2002/086479 A1 (REINBERG ALAN R) 4 July 2002 (2002-07-04) paragraphs '0020! - '0033!; figures 2-11	1-5,13, 14
X	US 6 180 450 B1 (DENNISON CHARLES H ET AL) 30 January 2001 (2001-01-30) column 4, line 29 - column 7, line 53; figures 1-9	9-12, 17-22
X	US 5 340 763 A (DENNISON ET AL) 23 August 1994 (1994-08-23) column 1, line 51 - column 5, line 46; figures 1-10	17-22
X	DE 44 47 804 C2 (MICRON TECHNOLOGY, INC.) 24 January 2002 (2002-01-24) paragraphs '0006! - '0020!; claim 1; figures 1-4	17-22

Further documents are listed in the continuation of box C.	Patent family members are listed in annex.
* Special categories of cited documents: "A" document defining the general state of the art which is not considered to be of particular relevance "E" eartier document but published on or after the international	 'T' later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention 'X' document of particular relevance: the claimed invention cannot be considered novel or cannot be considered to
filing date 'L' document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) 'O' document referring to an oral disclosure, use. exhibition or other means 'P' document published prior to the International filing date but	"Y" document of particular relevance; the claimed involve an inventive step when the document is taken alone "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such docu- ments, such combination being obvious to a person skilled in the art. "&" document member of the same palent family
later than the priority date claimed Date of the actual completion of the international search	Date of mailing of the international search report
18 February 2005	28/02/2005
Name and mailing address of the ISA	Authorized officer
European Patent Office, P.8. 5818 Patentiaan 2 NL - 2280 HV Rijswijk Tal. (+31-70) 340-2040, Tx. 31 651 apo nl. Fax. (+31-70) 340-3016	Neumann, A

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INTERN TIONAL SEARCH REPORT

onal Application No. PCT/US2004/027898

		PCT/US200	14/027898	
(Continua	tion) DOCUMENTS CONSIDERED TO BE RELEVANT			
ategory °	Citation of document, with indication, where appropriate, of the relevant passages		Relevant to claim No.	
	US 2002/090779 A1 (JANG SE-MYEONG) 11 July 2002 (2002-07-11) paragraphs '0022! - '0038!; figures 4-13		1-22	
ļ	US 2002/163026 A1 (PARK HONG-BAE) 7 November 2002 (2002-11-07) abstract; figure 3		1-22	
;				
	·			
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		•		

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INTERM TIONAL SEARCH REPORT

Information on patent family members

Inte. onal Application No PCT/US2004/027898

Patent document cited in search report		Publication date		Patent family member(s)	Publication date
US 2002086479	A1	04-07-2002	US	6403442 B1	11-06-2002
03 20020004/3	V.T	ü	us	2001026974 A1	04-10-2001
			US	2002039826 A1	04-04-2002
US 6180450	B1	30-01-2001	U\$	6037218 A	14-03-2000
00 0100400	-		US	5652164 A	29-07-1997
			US	5498562 A	12-03-1996
US 5340763	Α	23-08-1994	DE	4404129 A1	18-08-1994
05 5040,00	•••		DE	4447804 C2	24-01-2002
			JP	2598607 B2	09-04-1997
			JP	7007087 A	10-01-1995
			us	5401681 A	28-03-1995
			US	5605857 A	25-02-1997 06-01-1998
			US	5705838 A	11-11-1997
			US	5686747 A	30-12-1997
			US US	5702990 A 5821140 A	13-10-1998
			US	5900660 A	04-05-1999
			U\$	6110774 A	29-08-2000
DE 4447804	C2	24-01-2002	US	5340763 A	23-08-1994
DE 4447604	UL.	24 01 2001	DE	4404129 A1	18-08-1994
			ĴΡ	2598607 B2	09-04-1997
			JP	7007087 A	10-01-1995
			US	5401681 A	28-03-1995
			US	5605857 A	25-02-1997
			US	5705838 A	06-01-1998
			US	5686747 A	11-11-1997
			us	5702990 A	30-12-1997
			บร	5821140 A	13-10-1998 04-05-1999
			US	5900660 A	29-08-2000
			U\$	6110774 A	Z9-U0-ZUUU
US 2002090779	A1	11-07-2002	KR	2002057698 A	12-07-2002
US 2002163026	A1	07-11-2002	KR	2002084481 A	09-11-2002